



EV550719147

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/075,172  
Confirmation No. .... 7318  
Filing Date ..... February 13, 2002  
Inventor..... Brian E. Cron  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 3723  
Examiner ..... Eziamara Anthony Ojini  
Attorney's Docket No. .... MI22-1804  
Customer No. .... 021567  
Title: Methods for Conditioning Surfaces of Polishing Pads After Chemical-Mechanical Polishing

**RESPONSE TO MAY 17, 2005 FINAL OFFICE ACTION**

Response to Accompany an RCE Filing

To: Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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**AMENDMENTS**